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FORM PTO-1449	Docket Number (Optional) 2133.061USU	Application Number 107211315 Not Yet Assigned
INFORMATION DISCLOSURE CITATION IN AN APPLICATION		Applicant Mund and Leib
(Use several sheets if necessary)	Filing Date Herewith	Group Art Unit Not Yet Assigned

U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
HEA	DE10222609.1A1	5/23/02	Germany				X
AEA	DE10222958.9A1	5/23/02	Germany				X
SEA	DE10222964.3A1	5/23/02	Germany				X
HEA	DE10252787.3A1	11/13/02	Germany				X
HEA	DE10301559.0A1	10/30/03	Germany				X
SEA	387175	5/15/65	Switzerland				X

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

<i>H. Saito</i>	XP-000819426, Sputtered Lead Silicate Glass Film for Multilevel Interconnections, Kato et al., 2419 Japanese Journal of Applied Physics Supplements, vol. 22 (1983) suppl. No. 22-1, Tokyo, Japan, pgs 167-170
<i>H. Saito</i>	XP-002251599, Eliminating The Step in Etched via Holes Interrupted Sputter Glass Deposition, Bialko et al., vol. 20, no. 7 (1977), IBM Technical Disclosure Bulletin, pg 26.

EXAMINER <i>Kim Almst</i>	DATE CONSIDERED 10/13/05
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.